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PATENT
Attorney Docket No.: SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Group Art Unit: 1763
Maximilian A. Biberger et al.)	Examiner: Ram N. Kackar
Serial No.: 09/912,844)	<u>TRANSMITTAL LETTER</u>
Filed: July 24, 2001)	162 N. Wolfe Road
For: HIGH PRESSURE PROCESSING)	Sunnyvale, CA 94086
CHAMBER FOR)	(408) 530-9700
SEMICONDUCTOR SUBSTRATE)	Customer No.: 28960

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Sir:

Enclosed please find a Supplemental Information Disclosure Statement and Form PTO-1449, including a copy of the reference contained thereon, for filing in the U.S. Patent and Trademark Office.

You will also find enclosed the associated Transmittal, Electronic Information Disclosure Statement, and United States Patent and Trademark Office Acknowledgment Receipt for the electronically filed Information Disclosure Statement (EFS ID #62626) filed on June 15, 2004.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 6-15-04

By: Thomas B. Haverstock
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicants

CERTIFICATE OF MAILING (37 CFR§ 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

- 1 -

HAVERSTOCK & OWENS LLP.
Date: 6-15-04 By: [Signature]



Attorney Docket No.: PATENT
SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Group Art Unit: 1763
Maximilian A. Biberger et al.)	Examiner: Ram N. Kackar
Serial No.: 09/912,844)	<u>SUPPLEMENTAL INFORMATION</u>
Filed: July 24, 2001)	<u>DISCLOSURE STATEMENT</u>
For: HIGH PRESSURE PROCESSING)	162 N. Wolfe Road
CHAMBER FOR)	Sunnyvale, CA 94086
SEMICONDUCTOR SUBSTRATE)	(408) 530-9700

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Sir:

The citation listed below, copy attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make this citation of official record in this application.

United States Patents or Published Patent Applications have been filed electronically (EFS ID #62590). Applicants have become aware of the following printed publication which may be material to the examination of this application:

- Japanese Patent Abstract JP 8-206485.

This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 6-15-04

By: Thomas B. Haverstock
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicants

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HAVERSTOCK & OWENS LLP.
Date: 6-15-04 By: [Signature]

FORM PTO-1449
(Modified)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No.: SSI-00501

Serial No.: 09/912,844

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(See Several Sheets If Necessary)

Applicants: Maximilian A. Biberger et al.

(37 CFR § 1.98(b))

Filing Date: July 24, 2001

Group Art Unit: 1763

U.S. PATENT DOCUMENTS

Examiner Initials		Serial / Patent Number	Issue Date	Applicant / Patentee	Class	Subclass	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
	AK	JP 8-206485	08/13/96	JP	B01J	3/06		X
	AL							
	AM							
	AN							
	AO							

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

	AP	
	AQ	
	AR	
	AS	
	AT	
	AU	
	AV	
	AW	
	AX	
	AY	
	AZ	

Examiner:

Date Considered:

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



**UNITED STATES PATENT AND TRADEMARK OFFICE
ACKNOWLEDGEMENT RECEIPT**

Electronic Version 1.1
Worksheet Version v1.1.1

Title of Invention	HIGH PRESSURE PROCESSING CHAMBER FOR SEMICONDUCTOR SUBSTRATE													
Submission Type:	Information Disclosure Statement													
Application Number:	09/912844	*09/912844*												
EFS ID:	62626													
Server Response:	<table border="1"> <thead> <tr> <th>Confirmation Code</th> <th>Message</th> </tr> </thead> <tbody> <tr> <td>ISVR1</td> <td>Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application</td> </tr> <tr> <td>ICON1</td> <td>\$915</td> </tr> <tr> <td>USPTOEFSNotice</td> <td>For assistance with e-filing a patent application, contact the Patent Electronic Business Center: Toll-Free Number: 1 (866) 217-9197 Website: http://www.uspto.gov/ebc/</td> </tr> </tbody> </table>		Confirmation Code	Message	ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application	ICON1	\$915	USPTOEFSNotice	For assistance with e-filing a patent application, contact the Patent Electronic Business Center: Toll-Free Number: 1 (866) 217-9197 Website: http://www.uspto.gov/ebc/				
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ICON1	\$915													
USPTOEFSNotice	For assistance with e-filing a patent application, contact the Patent Electronic Business Center: Toll-Free Number: 1 (866) 217-9197 Website: http://www.uspto.gov/ebc/													
First Named Applicant:	Maximilian Biberger													
Attorney Docket Number:														
Timestamp:	2004-06-15 17:33:58 EDT													
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6/15/2004

Acknowledgement Receipt

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package-data	us-package-data.xsl	19263
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6/15/2004

TRANSMITTAL	
Electronic Version v1.1 Stylesheet Version v1.1.0	
Title of Invention	HIGH PRESSURE PROCESSING CHAMBER FOR SEMICONDUCTOR SUBSTRATE
Application Number:	09/912844 *09/912844*
Date:	2001-07-24
First Named Applicant:	Maximilian A. Biberger
Confirmation Number:	5915
Attorney Docket Number:	
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>	
Submitted by:	Elec. Sign. Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/ Attorney

Documents being submitted	Files
us-ids	SSI00501-usidst.xml
	us-ids.dtd
	us-ids.xsl
Comments	

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	HIGH PRESSURE PROCESSING CHAMBER FOR SEMICONDUCTOR SUBSTRATE
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Application Number: 09/912844 *09/912844*
Confirmation Number: 5915
First Named Applicant: Maximilian Biberger
Attorney Docket Number:
Search string: (5186594 or 5769588 or 5906866 or 5975492 or 6122566 or
6355072 or 6454519).pn.

Certification: This Information Disclosure Statement was submitted under the following conditions, which satisfies the requirement under 37 CFR 1.97(e). The filer certified:

That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

Init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5186594	1993-02-16	Toshima et al.			
	2	5769588	1998-06-23	Toshima et al.			
	3	5906866	1999-05-25	Webb			
	4	5975492	1999-11-02	Brenes			
	5	6122566	2000-09-19	Nguyen et al.			

	6	6355072	2002-03-12	Racette et al.	81
	7	6454519	2002-09-24	Toshima et al.	81

Signature

Examiner Name

Date

